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Appl. No. : 10/023,940  
Applicant : Jin-goo PARK  
Filed : December ~~21~~, 2001  
TC/A.U. : 1746  
Examiner : Michail Kornakov

Confirmation No. 7717

Docket No. : 1751-0297  
Cust. No. : 06449

**Mail Stop Non-fee Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT**

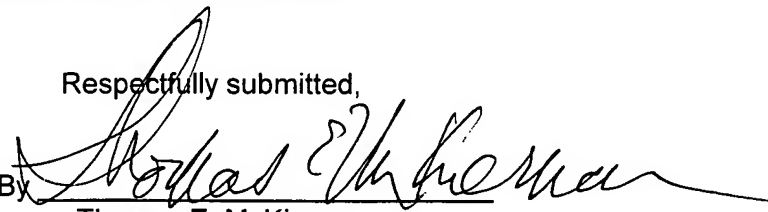
Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In response to the restriction requirement mailed February 17, 2004, the Applicants hereby elect Group II, consisting of claims 3 and 4, drawn to a method of cleaning a wafer, classified in class 134, subclass 1. Applicant reserves the right to pursue the non-elected claims in a divisional application.

Favorable action on the elected claims is earnestly solicited.

Respectfully submitted,

By 

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